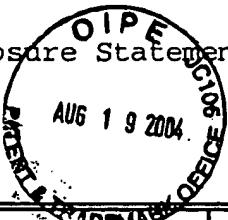


Information Disclosure Statement
 USSN 10/772,112
 August 16, 2004
 Page 3



Form PTO-1449 (Modified)		ATTY DOCKET NO. B-4246DIV 621598-8	U.S. SERIAL NO. 10/772,112
LIST OF PATENTS AND PUBLICATIONS STATEMENT		APPLICANT(S) Daniel YAP	
		FILING DATE February 3, 2004	GROUP 2818

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	ISSUE DATE	NAME	CLASS	SUBCLASS	FILING DATE or 102(e) DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

WT	Chan, W.K., et al., "Grafted Semiconductor Optoelectronics," IEEE Journal Of Quantum Electronics, Vol. 27, No. 3, pp. 717-725 (March 1991).
MH	Yi-Yan, A., et al., "Semiconductor-Film Grafting: A New Approach to OEICs," Circuits & Devices, pp. 26-30 (May 1992).

EXAMINER <i>Murphy, J.W.</i>	DATE CONSIDERED <i>09/02/04</i>
---------------------------------	------------------------------------

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 509; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.